



AF/2881

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kouchi Nagai et al.Confirmation Number: **4556**Serial No.: **09/815,282**Group Art Unit: **2881**Filed: **March 23, 2001**Examiner: **Paul Gurzo**For: **SCANNING ELECTRON MICROSCOPE**Attorney Docket: **010391****STATEMENT OF SUBSTANCE OF INTERVIEW**

Commissioner for Patents, P.O. Box 1450

Alexandria, VA 22313-1450

Date: **December 10, 2003**

Sir:

A complete reply will follow. The Applicants now submit the required statement of the substance of the personal interview of November 12, 2003, as follows:

The working order of instant application and teaching of ranges in the prior art was discussed.

Respectfully submitted,

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